

Reply Under 37 C.F.R. § 1.116 - Expedited Procedure - Technology Center 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Daijiro INOUE, et al.

Application No.: 10/663,714

Customer No.: 20277

Filed: September 17, 2003

Confirmation No.: 2234

Group Art Unit: 2826

Examiner: SEFER, Ahmed N.

Title: NITRIDE-BASED SEMICONDUCTOR LIGHT-EMITTING DEVICE

OK TO ENTER: /AS/

RESPONSE TO OFFICE ACTION UNDER 37 C.F.R. § 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

These Remarks are submitted in response to the final Office Action dated June 16, 2008, pursuant to 37 C.F.R. § 1.116. A certified English translation of the Japanese priority document, JP 2002-271968, is attached to this response.

Remarks begin on page 2 of this paper.